



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#12/Ex
5/10/03
Suria

APPLICANT : Dong-Su Kim

SERIAL NO. : 09/899,784

EXAMINER : Fernando L. Toledo

FILED : July 5, 2001

ART UNIT : 2823

FOR : METHOD OF FABRICATING SILICA MICROSTRUCTURES

Certificate of Mailing Under 37 CFR 1.8

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to the ASSISTANT COMMISSIONER FOR PATENTS, WASHINGTON, DC 20231 on April 28, 2003.

Steve S. Cha, Reg. No. 44,069
(Name of Registered Representative)


(Signature and Date)

PETITION FOR ONE MONTH EXTENSION OF TIME

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

Dear Sir:

Applicants hereby request that the period for responding to the Office Action, now set to expire on March 27, 2003, be extended by one (1) month, so as to expire on April 28, 2003 as April 27, 2003 was a Sunday.

As Applicants are associated with a large entity, a check in the amount of \$110.00 is enclosed to cover the one-month extension herein requested. The Commissioner is further authorized to charge any deficiencies or to credit any overages to Deposit Account No. 502-470.

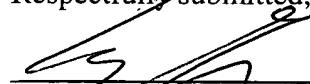
Favorable action on this Request for Extension of Time is courteously solicited.

05/05/2003 NGBREM1 00000094 09899784

02 FC:1251

110.00 OP

Respectfully submitted,


Steve Cha
Attorney for Applicant(s)
Registration No. 44,069

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Date: April 28, 2003

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